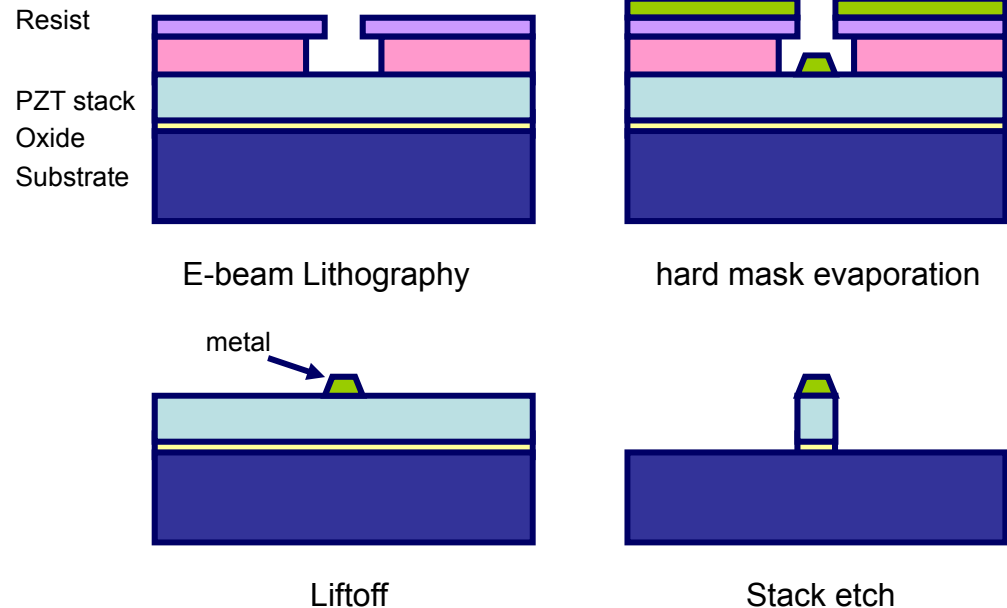
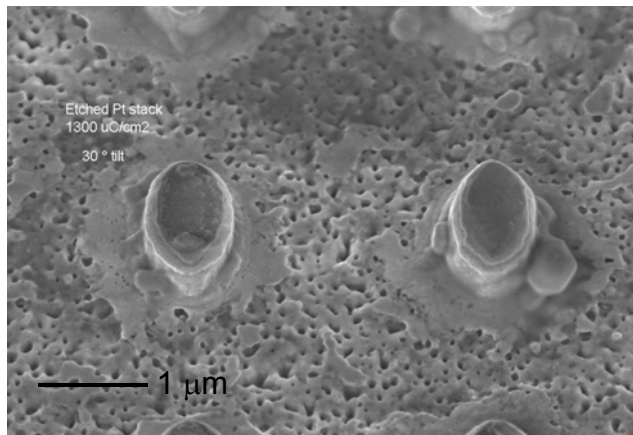
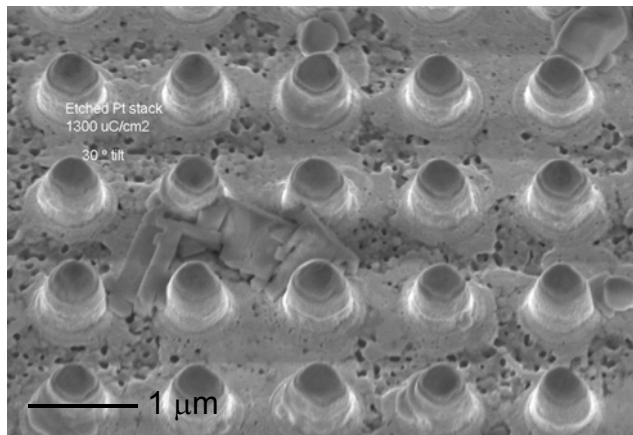


# PZT Nanopillar Arrays

Gamma Company, Escalon, CA



Scanning electron microscope images (left) of circular and oval PZT nanopillars. The process (top) uses e-beam lithography to pattern a metal hard mask followed by high-aspect ratio etching of a PZT thin film.